made of low-resistivity materials. In the open state the moving contact is retracted from the fixed contact by applying an **Materials** opening force to overcome outside atmospheric pressure and
possible contact welding. The metallic bellows (9) provides the
necessary motion in vacuum, tightly sealing against the at-
mospheric pressure. The ceramic or glas monly called a vacuum arc although in fact it is burning in $\frac{3}{11}$ High-purity copper is often labeled as 5N, that is, 99.999%

(7) ceramic-to-metal junction; (8) contact tip; (9) bellows; (10) end plates. The contact tips have to provide a good electrical con-

the hot ionized vapors of the contact-tip material. Some literature refers to it as a metal vapor arc. The arc products, hot vapors, ions, electrons, and microdroplets of molten material are sputtered from the interelectrode area outward due to the pressure differential between the arc and surrounding vacuum ambient. In order to avoid coating the inside of ceramic insulators with conducting films of condensing vapors, the contacts are surrounded by an ion shield (4), typically made of metallic material. Notice that the shield is normally electrically floating, that is, not connected to either electrode. An additional shield (5) is often used to protect the bellows. Although coating of the bellow would not have any dielectric consequences, the exposure to high temperatures of the arc might damage the rather fragile component. The end plates (10) are holding the contacts in place and provide the seal and mechanical support for the bellows.

Manufacturers of vacuum switches utilize their own designs with modifications to the basic schematic shown in Fig. 1. For example, in order to reduce the number of components **VACUUM SWITCHES** and cost only a single ceramic or glass envelope is used. In this case the ion shield would typically be electrically con-**FUNDAMENTAL DESIGN OF THE VACUUM SWITCH** nected to one of the electrodes. In other designs the inside surface of the ceramic is shaped with special grooves so even **Components** components when the vapors are deposited onto the exposed ceramic sur-The vacuum switch represents a family of devices ranging faces, the remaining, shadowed grooves provide the necessary widely in different types and applications. However, despite lows so it extends cher solutions include

pure, or OFHC, that is, oxygen-free, high conductivity. Such copper is commonly available today but it is rather soft and ductile and therefore difficult to machine. The material for the contact tips is most often proprietary and specific to each manufacturer. Various alloys and sintered materials composed of copper or silver mixed with chromium, bismuth, tungsten, etc., are used. For high power switches a mixture of chromium and copper is now almost universally used. The main two functions of the contact tip are (1) to allow the arc to burn easily in its vapors so as to provide good conduction Figure 1. Vacuum switch components (shown in open state): (1) fixed
contact stem; (2) moving contact stem; (3) contact-arc-control geome-
try; (4) ion shield; (5) bellows shield; (6) ceramic or glass insulators;
(7) ceram

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Table 1. Materials Commonly Used for Vacuum Switch Manufacturing

Material	Component or Its Function
High purity (5N) OFHC copper	Contact stems, arc control con- tact, end plates
Copper-chromium, copper- bismuth, silver-tungsten, etc.	Contact tip
Stainless steels	Bellows, ion shields, bellow shields, end plates, additional components of arc control con- tacts
Ferromagnetic steels (Nickel) steels. \ldots	Ion shields, bellow shields, end plates
Aluminum oxide-based ceramics and glasses	Envelopes, ion shield
Eutectic brazing materials (Silver-based)	All connections and junctions
Getters	Continuous pumping of sealed switch

the order of 1,000,000 mechanical operations without fatigue.
Some switches utilize ferromagnetic steel rather than stain-

the order of 1,000,000 mechanical operations without it
aligue. as low as 10⁻¹⁸ Torr. Any pressure less than 10⁻⁵ Torr plays
Some switches utilize ferromagnetic steel rather than stain-
no part in the operation of the arc capture the gas molecules and deposit them on the sur-**TYPES OF VACUUM SWITCHES AND THEIR APPLICATIONS** rounding ion shield. The gas molecules bonded with the metal vapor molecules form a layer that can be safely stored on the surface of the shield. Chromium based materials are particu-

High-Current Interrupters larly effective at this self pumping action. The primary functions of these devices are to carry normal

(typically class 100) is required. The assembly area has to be dust-free and the components have to be free of oxides and oil residues from machining. After chemical cleaning all the parts of the switch are dry-assembled together and placed on special jigs to be put into the vacuum furnaces for final processing. Modern vacuum furnaces allow a large number of devices to be processed simultaneously. With the load of dry-assembled bottles inside, the furnace is closed and the temperature is raised. At the same time the chamber is evacuated. This accomplishes two things. First, the residual gases and other volatile impurities are freed off all the surfaces and pumped out. Second, when the temperature exceeds the melting point of the brazing washers the braze melts and brazes the components together. The same principle is also used for the final sealing off of the device. In some designs both processes are performed in one operation called ''one shot seal off.'' Sophisticated computerized process-control technology is necessary to ensure the proper temperature control, duration of individual cycles, etc. Quality control and highest repeatability of the furnace operation are critical. A load of vacuumnection in the closed state as well as the ability to close onto
suriching devices is typically processed within 24 h to 36 h.
a fault current without welding to each other. In the last sev-
checked for proper vacuum press sure of the healthy switch could be as high as 10^{-5} Torr and as low as 10^{-10} Torr. Any pressure less than 10^{-5} Torr plays

load current when closed and to be able to interrupt very high **Manufacturing** short-circuit currents in the event of a fault in the power sys-The manufacturing process of vacuum switches resembles tem. Therefore, they are of a larger size, employing heavy con-
that used in the silicon wafer industry. A clean-room facility tacts with sophisticated arc-control geo tacts with sophisticated arc-control geometries. The shield is

shown as diffuse). Shown as diffuse.

rate under high current and to keep the arc in the diffuse **Breakdown and Field Emission in Vacuum** mode for interruption at current zero (see the section entitled ''Electrical Characteristics''), magnetic fields are employed in- It is generally agreed that breakdown in vacuum is a combiated by the high current itself. There are two generic types of (RMF) or axial magnetic field (AMF). Both principles are section briefly describes the three mechanisms.
shown in Fig. 2. In the RMF contacts parallel slots are cut According to the Fowler–Nordheim theory, which draws on counterclockwise. When the switch current passes through the contacts it forms a loop as shown in Fig. 2(a). This loop generates a radial magnetic field that in turn produces an azimuthal electromagnetic force according to the Lorenz force, $F = I \times B$. This forces the arc to rotate around the electrode perimeter typically 3–6 times per one-half cycle of power frequency current. The fast rotation of the arc cools the electrodes and uniformly distributes the arc products throughout the space. In Fig. 2(b) the cuts are in the same directions for both electrodes. The flowing current forms an azimuthal loop that produces an axial magnetic field, similar to a single turn of a solenoid around the contacts. Although the axial magnetic field does not move the arc roots, it causes the arc to spread evenly across the contact and keeps it in so-called diffuse mode, that is, as many separate small current arcs easily **Figure 3.** Potential energy distribution between the metal and manageable during interruption. vacuum.

Load Switches

Load switches are designed to carry and switch only normal load currents with limited fault-current-interruption capability. Thus they are lighter and less expensive to manufacture. Most of them do not have any arc-control geometries but their contact stems are suitable for providing good thermal conduction of heat from the contact area to the outside of the device. In all vacuum switches the heat dissipated as a result of *I*² *R* power, where *I* is a current through the switch and *R* is a resistance of the contacts in closed state $(5 \mu \Omega)$ to $50 \mu \Omega$), has to be removed outside the device by thermal conduction through the stems since the convection and radiation of heat are insignificant. Load switches are expected to operate more frequently than the high-current interrupters.

Contactors

These switches are used for lower voltages and currents and very frequent operations. Typical applications would include motor control and capacitor bank switching. The insulators are therefore smaller in diameter and length; the contacts are (**b**) also smaller with no arc control. The contact gap is typically Figure 2. (a) Radial magnetic field arc control geometry (arc shown of the order of 4 mm or less. The contactors are durable and as constricted). (b) Axial magnetic field arc control geometry (arc often capable of 5,000,00

ELECTRICAL CHARACTERISTICS

also thicker to withstand the heavy bombardment of plasma

and vapor from the high current arc. These switches are ex-

pected to perform of the order of 10,000 mechanical opera-

tions but have a lower life expectancy for

side the contacts. These magnetic fields are typically gener- nation of field-emission processes according to the Fowler-
ated by the high current itself. There are two generic types of Nordheim mechanism. Schottky emissio arc-control geometries, producing either radial magnetic field ing of the microscopic sites of the electrode surface. This

shown in Fig. 2. In the RMF contacts parallel slots are cut
around the circumference of both electrodes but in opposite quantum mechanics, the electrons inside the metal electrode around the circumference of both electrodes but in opposite quantum mechanics, the electrons inside the metal electrode
directions that is one electrode clockwise the other one at room temperature have their energy below t directions, that is, one electrode clockwise, the other one at room temperature have their energy below the potential counterclockwise. When the switch current passes through barrier described as the work function (see Fig

illustrates the potential energy distribution across the inter- geometric surface area of the cathode, especially for the flat face of the metal and vacuum when an external electric field electrodes since the emission current density is higher at the is applied, as shown by the dashed line. The energy of the tips of the protrusions, where β is high, and lower or zero in electrons inside the metallic electrode (cathode) lies in the the valleys. In actual vacuum switches the tips and protruband as seen in Fig. 3, the highest energy being at the Fermi sions are the results of machining the contacts and mechanilevel. In such a case it is impossible, from the deterministic cal opening and closing operations as well as arcing. Moderpoint of view, for electrons to escape from the metal into the ate arcing of the contacts actually conditions the contacts and vacuum and proceed to the right, in the direction of the ap- improves the surface structure (lower β). As an example, two probability that the electrons can tunnel through the potential barrier even without having the required energy Φ . This after a few tens of repeated arcs. This conditioning effect of tunnel effect depends on the width of the barrier, *d*. It is easy arcs is often used in the manufacturing of vacuum switches. to observe that the width of the barrier is also dependent on The worst microprotrusions can be created by opening the the strength of the external field: the higher the field the nar- vacuum contacts under no current. rower the barrier. The Fowler–Nordheim (FN) equation de- Breaking the microwelds between the two contacts in the

$$
\log_{10}\left(\frac{J}{E^2}\right) = -\log_{10}\left(\frac{\Phi t^2(y)}{1.54 \times 10^{-2}}\right)
$$

$$
-\frac{6.83 \times 10^9 \nu(y) \Phi^{3/2}(1/E)}{2.3026} \tag{1}
$$

tric field strength, and $y = 3.795 \times 10^{-3} E^{0.5} / \Phi$. $\nu(y)$ and $t(y)$ rather than tunnel through it. The required energy is, of are functions of *y* and therefore E but do not vary significantly course, Φ , the work function. As in the case of FN theory the with the values of the field and are often assumed as con-
potential barrier also depen with the values of the field and are often assumed as con-
stants of depends on the external field, the contract depends on the external field, the lower the barrier height. stants. If one defines the current density as $J = I/A$, where higher the field, the lower the barrier height.
I is the emission current and A is an effective emission area. The most obvious mechanism for emitting the elec I is the emission current and A is an effective emission area The most obvious mechanism for emitting the electrons of the electron of the el of the electrode, and the electric field strength as $E = \beta V/l$, from the surface is the thermal energy that can be delivered
where β is a so called field ophancoment forter V is the yolt to the electrons to increase the where β is a so-called field enhancement factor, *V* is the volt-
are applied between the electrodes and *l* is the distance be. allow them to jump more easily over the potential barrier. age applied between the electrodes, and *l* is the distance be-
twoon the electrodes (gp). \mathbb{F}_{q} (1) on he epplied experiment allows the mail energy alone is not sufficient to produce tween the electrodes (gap), Eq. (1) can be applied experimental and a curve of I versus V plotted for a given
tally and a curve of I versus V plotted for a given
experimental arrangement. If plotted on a logarithm very important indicator of the conditions of the surface mi-
crostructure of the cathode and therefore sought after by de-
signers and users of high-voltage vacuum devices. Since all
practical metallic surfaces have a ce roughness (Fig. 4) it is likely that at the peaks of the surface
microdisturbances, or protrusions, the effective electric field
reach values as high as 10^9 A/m² to 10^{10} A/m² or more. Some
will be greater than will be greater than V/l by a certain factor (β) greater than
1. To use the FN equation for estimation of β it is necessary
to know the value of Φ . For copper and similar materials $\Phi =$
1. To use the FN equatio 4.5 eV. The intercept of the FN logarithmic curve with the $\frac{1}{2}$ in practical vacuum switches the possible breakdown sce-
ordinate can also be used to calculate A, the effective emission nario is as follows. When the area of the surface. It should be understood that *A* is not a

two emission sites. full collapse of the voltage during breakdown also depends on

plied field. However, quantum mechanics allows for a finite flat electrodes in vacuum 2 mm apart might withstand \sim 25 kV in the first trial but might support in excess of ~ 70 kV

scribes the relationship between the current density resulting absence of a smoothing action of the arc produces extremely from this effect and the applied electric field. sharp surface structures of the order of $10-20 \mu m$ in size. Of course, any current switching operation would tend to remove these protrusions.

The Schottky theory proposes another mechanism for the emission of electrons from the cold (room-temperature) cathode. It states that with certain probability some electrons within the metal at the higher end of the energy distribution where *J* is the current density, Φ , the work function, *E*, elec- will have enough energy to jump over the potential barrier *tric* field strength and $y = 3.795 \times 10^{-3}F^{0.5}/\Phi_{1/2}$ and $f(y)$ rather than tunnel throu

trons to escape from the tips of the microprotrusions (Fig. 4). This electron current triggers intensive Joule heating of the tips and possible melting, thus enhancing the emission even further. As a simple rule of thumb one can assume that for a typical, conditioned vacuum switch, the electrode gap can support electric fields of the order of 30 kV/mm to 40 kV/mm. This value could be much less if the temperature is high, if the profile of the surface is rough, or if the gap is still filled with plasma residues from the previous arcing. Freshly conditioned and polished surfaces can support higher values. Typical breakdown is very fast and takes of the order of single-**Figure 4.** Schematic profile of the microsurface of the electrode with digit nanoseconds to precipitate. One has to realize that the

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the external electrical circuit, especially its characteristics at high frequencies. where *n* is a density of the plasma (both electrons and ions,

species results in the net current density $i = ne(\nu_a - \nu_b)$. $n_e = \neg n_i$, *e* is an electronic charge, ν_e is a drift velocity of the **Vacuum Arc** electron cloud, and ν_i is velocity of the ion flux. Since the elec-If the external power eircuit can provide sufficient current, tron mass is much lower compared to the ion mass (several power and the between the beam of the mass (several are the fluit of the mediator of the state and th

spots merge together in the constricted arc mode. Not only does the resulting cluster of spots cause intensive localized cathode heating but the concentrated flux of ions melts the anode surface and initiates an anode spot [Fig. 5(b)]. The anode spot is much larger and hotter and contributes a significant amount of its own plasma to support the discharge. To summarize, both electrodes are active in the discharge and both have localized, anchored large hot spots producing plasma and metal vapor. If this is the case, the interrupting performance of this columnar arc at zero current is very poor and typically, for power system applications, failure to interrupt results unless the arc is made to move by means of radial magnetic field geometry as described previously. The arc voltage is higher than that in the diffuse mode, of the order of 100 V or more. This causes more power dissipation $(V_{\text{arc}}I_{\text{arc}})$ and magnifies the constriction effect even further.

Current Chopping

At very low currents the arc tends to become unstable, that is, thermodynamic processes inside the cathode spot are not balanced. This is often the case when switching an unloaded transformer or a high-impedance load, for example. When the current in the last existing cathode spot drops below the critical minimum value the arc could spontaneously extinguish (**b**) itself. This would abruptly terminate the flow of the re-**Figure 5.** Two modes of vacuum arc existence. (a) Diffuse arc (only maining current and cause a steplike transient. This current one cathode spot is shown); (b) constricted arc. chopping is a function of the contact material, that is, the

rent chopping.

composition of the metal vapor of the arc, as well as capaci-
tance and inductance values of the external circuit immedi-
ately adjacent to the switch. Electrodes made of refractory
metals (molybdenum or tungsten) tend to chopping currents (1 A to 3 A range). The influence of the $(30-40 \text{ kV/mm})$; therefore only short gaps are re-
electrical circuit capacitance and inductance can be explained $(30-40 \text{ kV/mm})$; therefore only short gaps are r with the help of Fig. 6 . When the current flows through the arc the parallel capacitance *C* tends to keep the arc voltage 8. Vacuum interrupters can be used in parallel for higher constant. At low currents the stability of the cathode spot is continuous current ratings due to the positive slope of in jeopardy and the arc tries to raise its voltage to increase the arc voltage-current characteristic. the power input $(V_{\text{arc}}I_{\text{arc}})$ to regain the production of the 9. Because of their excellent dI/dt interrupting capabiliplasma. The parallel capacitance restricts the voltage in- ties and fast dielectric recovery, vacuum switches can crease; therefore the higher the capacitance, the higher the also interrupt high-frequency transient currents and chopping current. On the other hand, the series inductance *L* cause potential for multiple reignitions and voltage estends to keep the arc current constant. When the current tries calation. These high-frequency events might be harmful to cease spontaneously the inductance helps maintain the to other power equipment such as motors, generators, current flow, so the higher the inductance the lower the cur- or transformers. rent chop.

In the early days the current chop was a potential serious problem for the users and designers of vacuum switches and **TYPICAL CAPABILITIES OF**
so contact materials, such as Cu. Cr. and Cu. Bi were dovel **COMMERCIAL VACUUM SWITCHES** so contact materials, such as Cu–Cr and Cu–Bi were developed. These modern materials have low current chopping and unless the application of the switch is particularly sensitive Table 2 summarizes the representative electrical characteris-
the channing is not considered a problem. In special cases ej. tics and ratings of commercial vac ther a different, extra-low chop contact material is employed, such as tungsten carbide silver (chop of \sim 0.5 A), or additional surge-suppressing devices are installed in the power circuit.

It should be pointed out that all of the properties mentioned previously of the vacuum breakdown and arc set the vacuum switches apart from all other switchgear technologies. Vacuum is a unique insulating and interrupting medium very different from air, oil, or SF_6 (sulfur hexafluoride). These unique properties can be utilized successfully if properly recognized, but could also result in misapplications and potential switching problems. The list below summarizes these properties.

- 1. Vacuum switches can interrupt very high currents in a small volume. The comparable $SF₆$ and air technologies require larger interrupting chambers and more components.
- 2. Vacuum switches can interrupt currents with very high rates of change, *dI/dt*, and therefore are applicable for switching higher frequencies. It is not unusual for the switch to be able to interrupt at a *dI/dt* of up to 1000 $A/\mu s$.
- 3. The dielectric recovery process after current interruption is extremely fast. Typically it is of the order of a few microseconds as compared with several tens of microseconds or even milliseconds for other technologies. This is related to the fact that the "memory" of the vacuum arc is very short.
- Figure 6. Effect of *L* and *C* of the external electrical circuit on cur-
seconds.
	- 5. The power dissipation of the vacuum switch is low since for any given current the arc voltage is low, provided
	-
	-
	-
	-

tics and ratings of commercial vacuum switches available to-
the chopping is not considered a problem. In special cases ei-
day. Technical literature on the subject reports trends of in-
ther a different extra-low chon con creasing ratings, and manufacturers are announcing new
products. It is expected that the new vacuum-switch products will soon include voltage ratings of 145 kV and above and current interruption ratings of 120 kA and above. The experts **Unique Electrical Properties of the Vacuum Switch** predict that vacuum-switch technology will be able to compete

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successfully with the $SF₆$ switching technology not only, as at present, in the power distribution systems (0.4 kV to 38 kV) but also, in the future, in power transmission applications (69 kV and above).

POWER SYSTEM AND INDUSTRIAL APPLICATIONS

A wide variety of vacuum switches is available on the market today. The commercial names for these devices are manufacturer-specific. The different categories of devices include vacuum circuit breakers, load switches, reclosers, sectionalizers, **Figure 7.** Principle of the dc switch commutation. *C* is charged becircuit switchers, and fault interrupters. The different appli- fore the switch *S* closes. VS is the vacuum switch, *L* and *C* are part cations might include capacitor bank switching, load switching, fault interruption, sectionalizing distribution feeders during faults, generator load current switching, and motor starting. The devices are available for both indoor and out- tacts are pulled apart, unless the current magnitude is midoor use. nute and below the level of a stable arc operation (current

gear that can be utilized in distribution substations, motor tinue arcing until it self-destructs. However, it is possible to control centers, etc. The indoor vacuum circuit breakers are bring the dc current to zero artificially by means of injecting typically of a size of a substation cubicle with metal railings a countercurrent that is equal and opposite to the main dc and rollers at the bottom of the unit so they can be withdrawn current. This is done with a circuit as shown in Fig. 7. When from their cubicles for interchangability and quick mainte- the device is called to operate the contacts of the vacuum nance. In most cases the actual vacuum interrupters are switch VS are drawn apart and at the same time the switch mounted vertically in the rear portion of the circuit breaker. S closes. The capacitor C discharges through L and S into the The outside of the vacuum interrupters is either air-insulated main switch VS, producing transient countercurrent *I*com. for standard applications but could be SF_6 insulated or solid When $I_{com} + I_{dc} = 0$ the net is zero, giving the arcing VS opporinsulated for compact, space-saving designs. In some coun- tunity to interrupt and recover. The frequency of the commutries retrofit designs of vacuum switches are offered to fit tating current is often high in order to reduce the size of the older oil switches in which current-interrupting oil units can L and C components. The vacuum switch can handle these be replaced with vacuum interrupters but the oil is still used high frequencies well, as described in the previous sections. as an insulating dielectric medium. Vacuum retrofits are also

available for air-magnetic circuit breakers as well.
TRIGGERED VACUUM GAP AND
mounted or pole mounted. For pole top mounted units low
TRIGGERED VACUUM SWITCH

which no commercialized, off-the-shelf devices are available. 500 V) pulse is applied between the trigger and the main elec-One such application is for the tokamak fusion machines in trode the microarc is ignited along the surface of the titanium which a high-magnitude transient current has to be switched hydrate, which releases a small amount of hydrogen atoms. on and off the magnetic coil of the machine. Although the The atoms are immediately ionized and the resulting mivoltage requirements for the tokamak are usually low, the croplasma diffuses rapidly to the main interelectrode gap. currents can easily reach 100 kA. This presents no problem This in turn precipitates the main breakdown and the arc. for the vacuum switch. It can switch this current many times The whole process takes only a few microseconds. during its lifetime with a high repetition rate. Both TVG and TVS operate on the same principle. The

The indoor applications are primarily metal-clad enclosed chopping). If no other means are taken, the device will con-

weight, low operating energy (a simple mechanism), and no
maintenace of vacuum interrupters are the primary advan-
maintenace of vacuum interrupters are the primary advan-
to contacts under current or overstressing the op bedded inside one, or both, of the electrodes. The insulating **OTHER APPLICATIONS** sleeve tubing holding the trigger is coated with a special material, such as titanium hydrate, that can serve as a minia-Vacuum can also be used for specialized applications for ture source of hydrogen atoms. When a low-voltage (300 V to

Another interesting application is interrupting dc current. main difference is that in the TVG all electrodes are fixed and Normally, a dc current will not be interrupted when the con-
therefore there is no means of establ therefore there is no means of establishing metallic contact

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conventional vacuum switch as shown in Fig. 1 with the ex- are sufficient. ception of the additional trigger. In TVS it is possible to ignite the arc precisely in the switch with the trigger and then dur-

ing arc conduction close the contacts. thus establishing a solid ABB Electric Systems Technology ing arc conduction close the contacts, thus establishing a solid ABB Electric Systems Technology of ϵ_{NN} and ϵ_{NN} and ϵ_{NN} are considered to ϵ_{NN} and ϵ_{NN} are considered to ϵ_{NN} and $\epsilon_{$ connection. Although today there are only a few isolated TVG or TVS products available on the market and the demand for such devices is rather low, the future trend in power systems might call for greater utilization of this unique technology.

VACUUM FUSE TUBES.

A vacuum fuse is essentially a device with two fixed contacts bridged together by a fusable element. This filament will melt and likely explode under high-current conditions, similar to a conventional fuse. When this happens the arc is drawn and the main electrodes take over the action. By utilizing the same arc-control principles (RMF or AMF) as described earlier the arc can then be extinguished at the first available current zero. Vacuum fuses are not popular because of their price which is typically higher than conventional air or sand fuses. Also, vacuum fuses, unlike other fuse technologies, do not have any current limiting capability. In isolated cases the application of a vacuum fuse might be justifiable.

OPERATIONAL SAFETY

When high voltage is applied between two electrodes in a vacuum environment a small electron emission current results. The cathodic electrons bombarding the surface of the opposite

Figure 8. Triggered vacuum gap.

between the main terminals. There are at least two major anode can generate a small amount of x-ray emission. Under designs of TVGs. Figure 8 illustrates a flat electrode design normal circumstances, that is, within the voltage rating of the in which the two main contacts are of the same general shape device and at the full open gap, the x-ray emission is zero or as the conventional vacuum switch (Fig. 1). In the other type, minimal. However, when the device is tested or operated at a the two electrodes are in the form of two sets of parallel rods fractional gap distance the same voltage may cause measurextending above the end plates, opposing each other and over- able X-rays. In such special cases manufacturers of vacuum lapping like fingers. The second design is believed to have a switches warn the users of the potential exposure and recomhigher current rating, lower contact erosion, and better use- mend that a protective lead shield, or equivalent means, be ful life. The used if any personnel are working close to the vacuum cham-In the TVS one of the contacts is moveable, similar to the ber. Normally, standard safety distances for electrical reasons

VACUUM TUBES. See GYROTRON; TRAVELING WAVE VALIDATION, MODEL. See MODELING AND SIMULATION.